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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re application of: Wu et al.

Attorney Docket No.:  
NOVLP091/NVLS-2889

Application No.: 10/820,525

Examiner: Maldonado, Julio J.

Filed: April 7, 2004

Group: 2823

Title: METHODS FOR PRODUCING LOW-K  
CDO FILMS WITH LOW RESIDUAL  
STRESS

Confirmation No: 8337

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CERTIFICATE OF EFS-WEB TRANSMISSION

I hereby certify that this correspondence is being transmitted electronically through EFS-WEB to Mail Stop AF, Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450 on March 4, 2009.

Signed: \_\_\_\_\_/Latonia Ervin/  
Latonia Ervin

**AMENDMENT E**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Office Action dated December 4, 2008 in the above-identified application, please amend the application as follows:

**Amendments to the Claims** are reflected in the listing of claims that begins on page 2 of this paper.

**Remarks/Arguments** are on page 7 of this paper.

A **Declaration under 37 CFR 1.131** of the inventors, with attached Exhibits A - H, accompanies this paper.